



***Unit of Materials and Optoelectronic Devices***

***University of Valencia***



[www.uv.es/umdo](http://www.uv.es/umdo)

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Current State of the work

Phone Conference March 4<sup>th</sup> 2015



# Outline

## **1-Deliverables and milestones**

## **2-Current Status of the work**

2.1-Plasmonic amplifiers

2.2-Photodetectors based on QDs and polymers



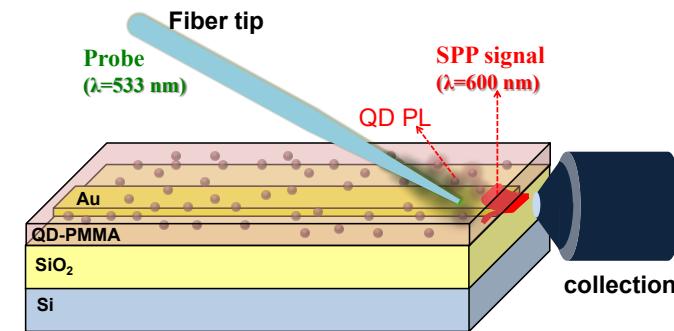
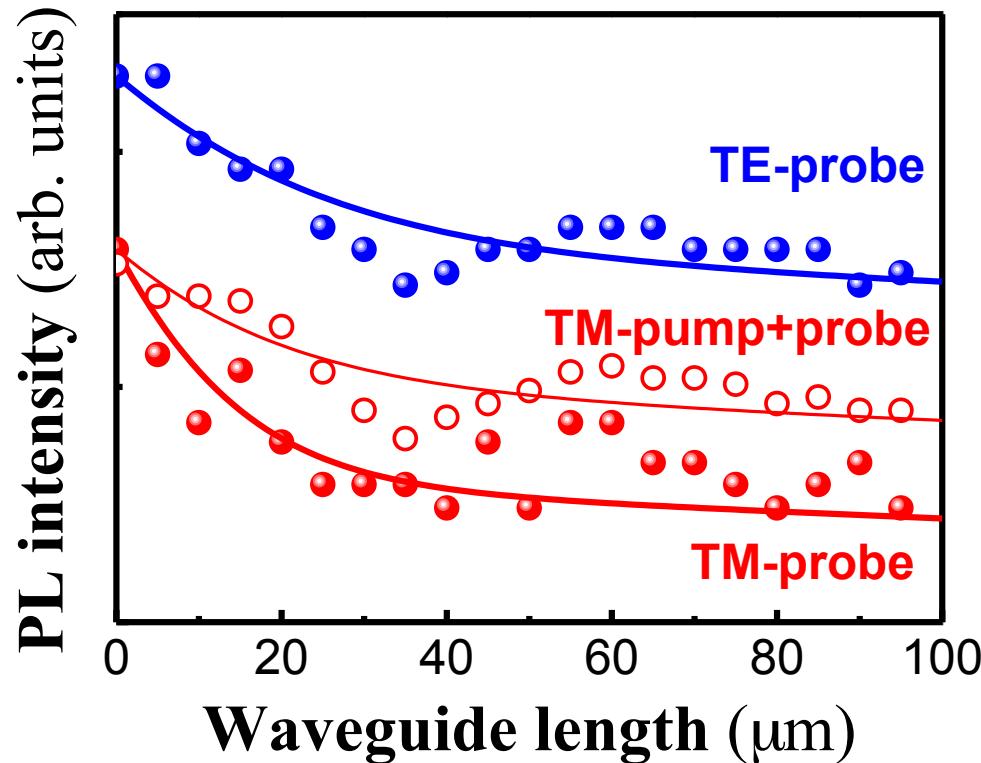
# Deliverables and Milestones

	<b>Names of the Milestones</b>	<b>Month</b>	<b>Partner</b>
<b>MS24</b>	Demonstration of SPP amplifiers with electrical injection exhibiting 10dB/cm gain	30	UVEG

	<b>Names of the Deliverables</b>	<b>Month</b>	<b>Partner</b>
<b>D4.5</b>	Report on plasmonic photodetectors	33	UVEG

## Method to characterize propagation length

Experimental set up with **Lock-in** amplifier to isolate de probe

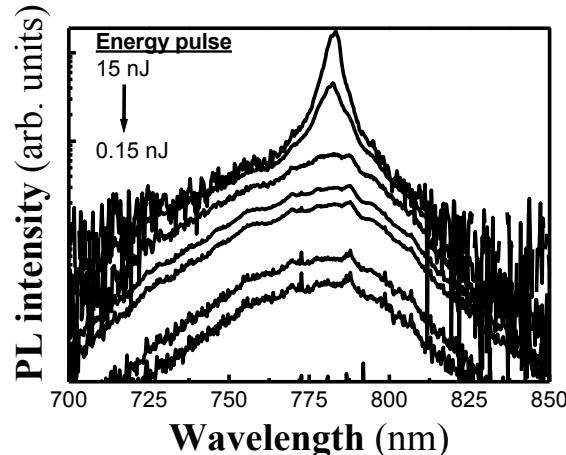


Probe:  $L_p = [6.25, 12.5] \mu\text{m}$  (theoretical  $11 \mu\text{m}$ )  
Pump+Probe:  $L_p = [11.1, 25] \mu\text{m}$   
(compensation (<50%))  
 New materials



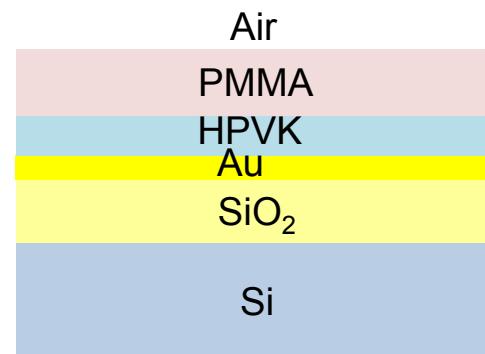
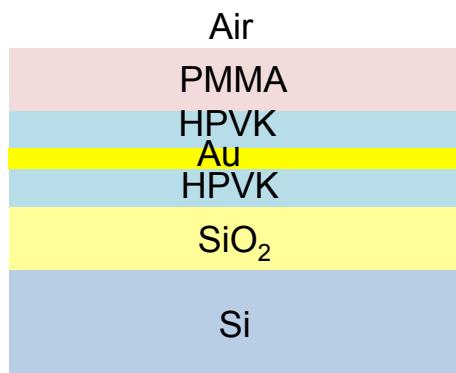
## Material with gain in dielectric waveguides

Hybrid halide perovskites ( $\text{CH}_3\text{NH}_3\text{PbX}_3$ )\* showed gain in dielectric waveguides



\*Iván Mora Optoelectronic and  
Photovoltaic group, Jaime I University  
(Castellón, Spain)

### New plasmonic waveguides with HPVK

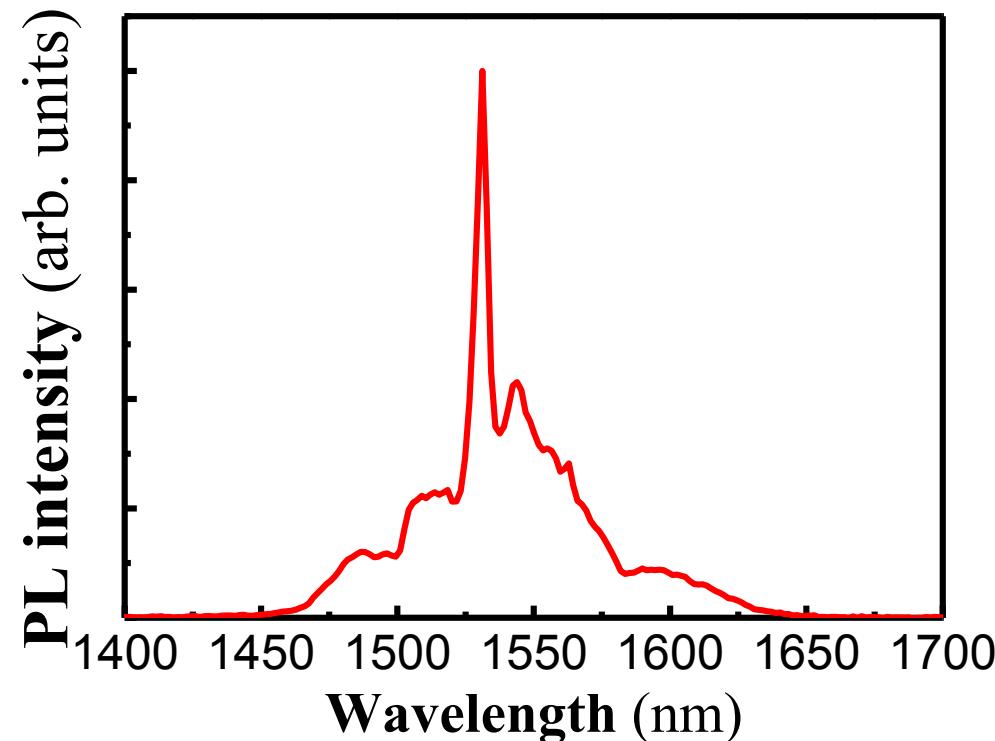


Structures under characterization



## Material with emission at 1550 nm

Nanoparticles\* with **Er-Yb** ions incorporated in polymer waveguides



\* Autonomous University of Madrid (Madrid, Spain), big NPs

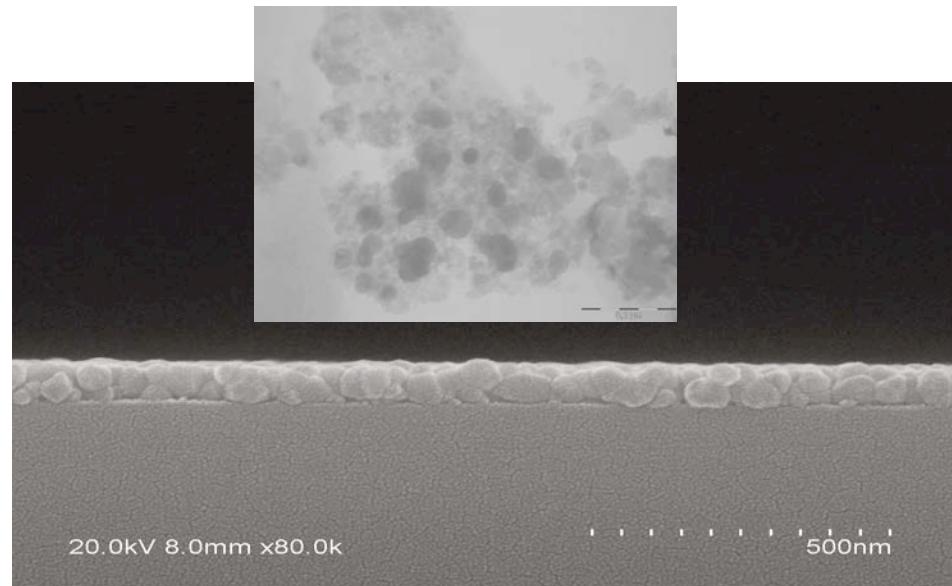
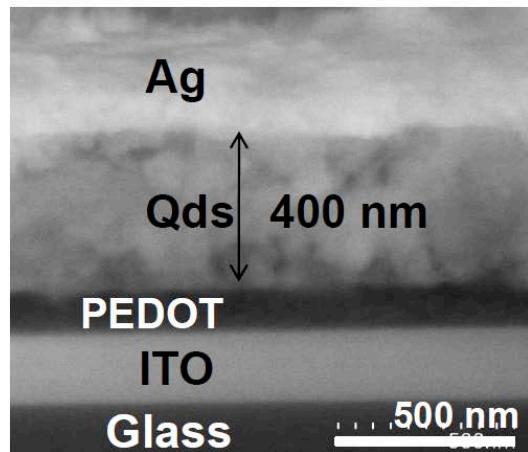
\* Institute of Molecular Science (UVEG), NPs 20 nm in diameter



## Schottky version:

- Working on transparent electrodes made by solution processing of Al:ZnO NPs

Cross Section



- New active layers made on lead free QDs of  $\text{Ag}_2\text{Se}$  and  $\text{Ag}_2\text{S}$

**Microgap version: new generation under processing**

**Nanogap version: electrodes under fabrication by e-beam**